LIST	OF PRIOR	ATTY. DOCKET NO. P-0533		APPLN. SERIAL NO. New U.S. Patent Application 1464995				
APPLICANT (PTO-1449)				APPLICANT(S) Tae-Kyu CHOI				
(110-1442)				CUSTOMER NO. 34610				
				FILING DATE August 28, 2003		GROUP 3 5 /		
		U	.S. PATENT D	OCUMENTS				
EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVE	NTOR NAME	CLASS	SUBCLASS		ING TE
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U.S. PATENT APPLICATIONS *APPLN. *FILING								
	NO-	DATE	*INVENTOR		CLASS	SUBCLASS		
	·	F	OREIGN PATENT	DOCUMENTS	·			
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY		CLASS	SUBCLASS	Trans Yes	lation No
HC	2002-0038428	05/23/02	Korea		-		X	
HC	2001-0038980	05/15/01	Korea				Х	
He	2001-0025591	04/06/01	Korea				Х	
HC	2001-156720	08/06/01	Japan				X	
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EXAMINER	DATE CONSIDERED 12/1/04							

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered.